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Search Results 11/10/2004 - 13:45:47

Search

Query :

((piezoelectric <or> component) <an

Query: ((piezoelectric <or> component) <and> silicone <near> (conductive <or> conducting <or> conductive) <near> (adhered <or> adhering <or> adhesive) <and> electrode)

7 documents out of 1613210 matched your query. Click on its number to view the details of the document.

Note: All document detail pages now appear on a new Browser Window.

1. [2151510](#) METHOD OF MOUNTING A PIEZOELECTRIC ELEMENT TO A SUBSTRATE 84%
2. [2451789](#) ASSAY PLATES READER SYSTEMS AND METHODS FOR LUMINESCENCE TEST MEASUREMENTS 68%
3. [2378190](#) MICROFABRICATED ELASTOMERIC VALVE AND PUMP SYSTEMS 63%
4. [1153794](#) TRANSCUTANEOUS CARBON DIOXIDE MEASURING SENSOR 55%
5. [2443782](#) PROCESS FOR MANUFACTURING ELECTRICALLY CONDUCTIVE COMPONENTS 21%
6. [2291280](#) USE OF A CARBOSILOXANE DENDRIMER IN ELECTROPHOTOGRAPHIC TECHNOLOGIES, ELECTROSTATIC RECORDING TECHNOLOGIES, AND ELECTROSTATIC PRINTING TECHNOLOGIES 10%
7. [2316196](#) IONTOPHORESIS DEVICE AND DRUG UNIT 08%

Searching PCT (Full Text)...

[Search Summary]

Results of searching in PCT (Full Text) for:

(Piezoelectric or component) and silicone near (conductive or conducting or
conductive) near (adhered or adhering or adhesive) and electrode: 7 records

Showing records 1 to 7 of 7 :

| | |
|---------------|---|
| Refine Search | (Piezoelectric or component) and silicone near (con |
|---------------|---|

Title

1. (WO 2004/045027) ANISOTROPIC **CONDUCTIVE ADHESIVE** AND FILM
2. (WO 03/096889) CORRECTION OF BAROMETRIC PRESSURE BASED ON
REMOTE SOURCES OF INFORMATION
3. (WO 02/102911) METHOD FOR **ADHERING** SUBSTRATES USING
ULTRAVIOLET ACTIVATABLE **ADHESIVE** FILM AND AN ULTRAVIOLET
IRRADIATION APPARATUS
4. (WO 02/097002) ULTRAVIOLET ACTIVATABLE **ADHESIVE** FILM
5. (WO 02/061010) METHOD FOR **ADHERING** SUBSTRATES USING LIGHT
ACTIVATABLE **ADHESIVE** FILM
6. (WO 99/18756) IMMERSIBLE PTC HEATING DEVICE
7. (WO 99/06496) **ADHESIVE** COMPOSITION FOR ELECTRICAL PTC
HEATING DEVICE

Search Summary

Piezoelectric NEAR conductive: 1690 occurrences in 463 records.

Piezoelectric NEAR adhered: 82 occurrences in 54 records.

(Piezoelectric NEAR conductive AND Piezoelectric NEAR adhered): 17 records.

component NEAR conductive: 8102 occurrences in 2213 records.

component NEAR adhered: 831 occurrences in 400 records.

(component NEAR conductive AND component NEAR adhered): 29 records.

((Piezoelectric NEAR conductive AND Piezoelectric NEAR adhered) OR (component
NEAR conductive AND component NEAR adhered)): 46 records.

silicone NEAR conductive: 1511 occurrences in 543 records.

silicone NEAR adhered: 260 occurrences in 158 records.

(silicone NEAR conductive AND silicone NEAR adhered): 4 records:

((Piezoelectric NEAR conductive AND Piezoelectric NEAR adhered) OR
(component NEAR conductive AND component NEAR adhered)) AND (silicone
NEAR conductive AND silicone NEAR adhered)): 0 records.

Piezoelectric NEAR conducting: 318 occurrences in 132 records.

Piezoelectric NEAR adhered: 82 occurrences in 54 records.

(Piezoelectric NEAR conducting AND Piezoelectric NEAR adhered): 2 records.

component NEAR conducting: 2058 occurrences in 914 records.

component NEAR adhered: 831 occurrences in 400 records.

(component NEAR conducting AND component NEAR adhered): 8 records.

((Piezoelectric NEAR conducting AND Piezoelectric NEAR adhered) OR (component

| | Type | L # | Hits | Search Text | DBs | Time Stamp | Comments |
|---|------|-----|------|---|--|----------------------|----------|
| 1 | BRS | L1 | 13 | piezoelectric and silicone adj3 conduct\$3 adj3 adhe\$4 and electrode\$1 | US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT; IBM_T DB | 2004/11/1 0 13:37 | |
| 2 | BRS | L2 | 10 | component same mount\$3 and silicone adj3 conduct\$3 adj3 adhe\$4 and electrode\$1 | US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT; IBM_T DB | 2004/11/1 0 13:38 | |

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